

Electronic Patent Application Fee Transmittal

Application Number:				
Filing Date:				
Title of Invention:	LOADING DEVICE FOR CHEMICAL MECHANICAL POLISHER OF SEMICONDUCTOR WAFER			
First Named Inventor:	Jung Hoon LEE			
Filer:	Jeffrey A. Wyand/Malika Ash Shakur			
Attorney Docket Number:	403835			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
National Stage Fee	1631	1	300	300
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				300